

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Takao OHNISHI, Masahiro MURASATO, Yuki
BESSHO and Nobuo TAKAHASHI

Serial No.: 10/630,887 Group Art Unit: 1762

Filed: July 30, 2003 Examiner: Lin, James

Conf. No.: 7943

For: MANUFACTURING METHOD OF PIEZOELECTRIC/
ELECTROSTRICTIVE FILM TYPE DEVICE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATION OF EFS
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I hereby certify that this paper is being transmitted via EFS to the Patent
and Trademark Office on October 5, 2006.


Gina M. Husak

AMENDMENT

Sir:

In response to the Office Action mailed July 6, 2006, please amend the above-
identified application as follows:

Amendments to the Specification are discussed on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Amendments to the Abstract are shown on page 9 of this paper.

Amendments to the Drawings are discussed on page 10 of this paper.

Remarks/Arguments begin on page 11 of this paper.

Appendices A & B, including a substitute specification and marked-up
specification, respectively, and **(1) Replacement Drawing Sheet** are attached hereto
after page 14 of this paper.